

PROPAGATING PARTIAL COHERENCE — HYBRID AND MORE



XIANBO SHI X-ray Science Division Advanced Photon Source Argonne National Laboratory

SOS workshop, Trieste, 3rd-7th October 2016



The Advanced Photon Source is a U.S. Department of Energy (DOE) Office of Science User Facility operated for the DOE Office of Science by Argonne National Laboratory under Contract No. DE-AC02-06CH11357.

OUTLINE

- Beamline optics simulation at APS
- HYBRID method
- Non-ideal optics: simulation
- Non-ideal optics: specification
- Mutual optical intensity propagation



BEAMLINE OPTICS SIMULATION AT APS APS upgrade project

8 new beamlines

- Coherence, nano-focusing, variable focal size
- Mirrors, CRLs, Zoom lens (a pair of dynamical focusing KB or CRL), ZPs
- Geometry: direct focusing, secondary focusing
- Beamline enhancement for all APS beamlines
 - Do no harm
 - Replacing/refurbishing critical elements

Assess current status and readiness of beamline optics for the APS upgrade

- Beamline optics database
 - Components, positions, cooling, metrology, papers describing beamline
- Measure and simulate all beamlines
 - Spot size, flux, vibration
 - Measured 19 beamlines (28 endstations)



BEAMLINE OPTICS SIMULATION AT APS

Simulation tools for beamline design

- Levels of simulation: accuracy vs efficiency
 - Calculator estimation: source size + ideal lens
 - Analytical formula (Mathematica/Excel):
 - Gaussian source profile
 - Optics acceptance (e.g., slits, mirror aperture, CRL transmission)
 - Demagnification + diffraction formula
 - Shadow-*HYBRID* (ShadowVUI and OASYS-ShadowOui version):
 - Real source intensity profile (Shadow, Spectra)
 - More accurate optics calculation (e.g., mirror shape error, heat load)
 - Ray-tracing + wavefront propagation to deal with partial coherence.
 - Full mutual coherence function propagation:
 - SRW
 - Mutual coherence function propagation (ESRF)
 - MOI code under development at APS and SSRF
- Optics simulation combined with x-ray testing



OUTLINE

Beamline optics simulation at APS

HYBRID method

- Non-ideal optics: simulation
- Non-ideal optics: specification
- Mutual optical intensity propagation

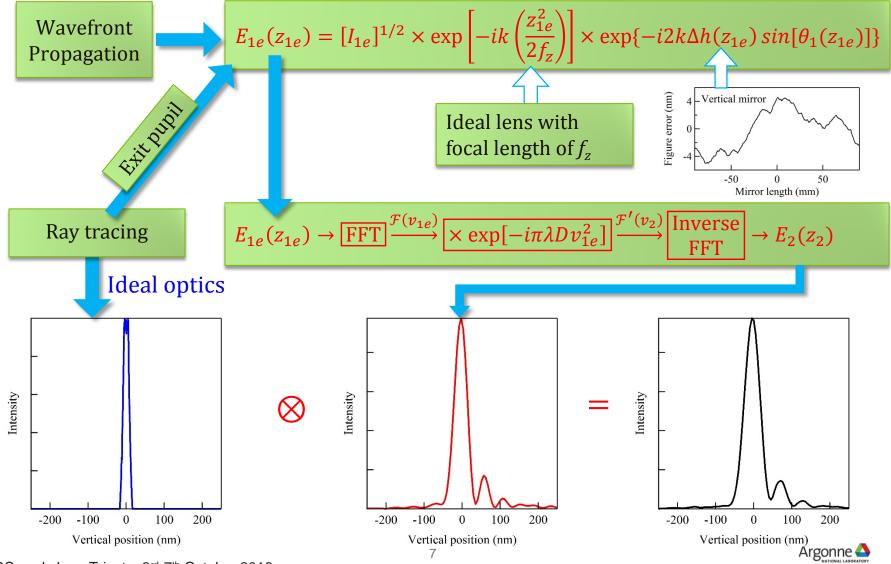


Motivation

- Geometrical ray tracing, e.g., SHADOW, RAY, McXtrace, …
 - Total intensity, beam size, mirror figure errors, reflectivity
 - Fast, robust, parameter optimization
 - No diffraction
- Wavefront propagation
 - Fourier optics, e.g., SRW
 - Stationary phase, e.g., PHASE
 - Diffraction effects
 - Partial coherent source: multi-electron simulation
 - Slow, result cannot be carried over
- Fast simulation tool for beamline design and optimization
 - Diffraction effects when beam is clipped
 - Simulate mirror figure errors as wave optics
 - Partial coherent source

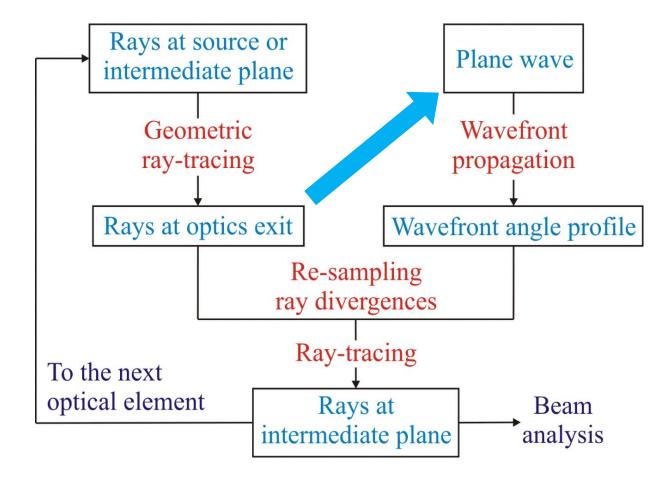


Basic idea – near-field mode



SOS workshop, Trieste, 3rd-7th October 2016

Basic idea – far-field mode



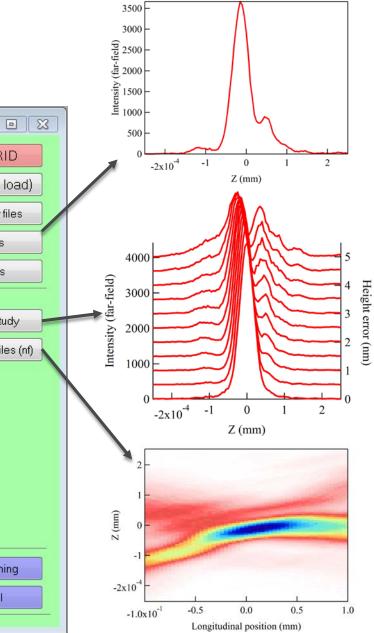
Iterative, valid in far-field approximation

X. Shi, et al., J. Synchrotron Rad. 21, 669 (2014).

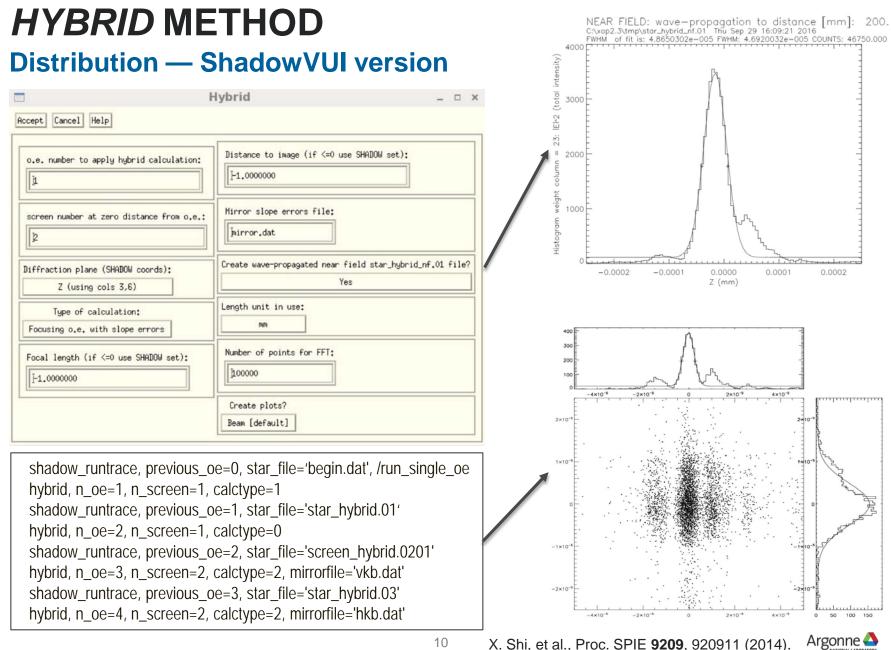


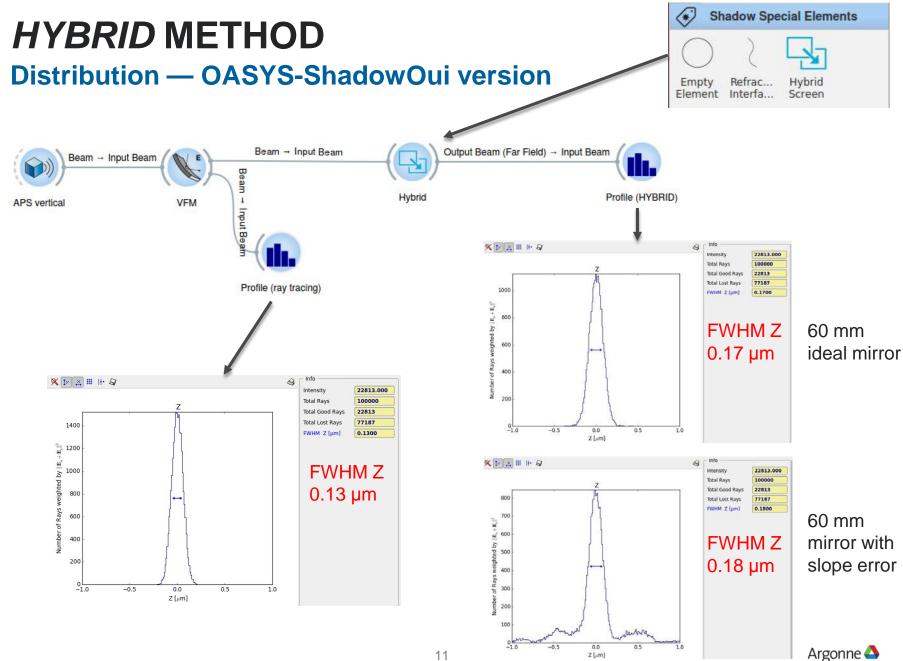
HYBRID METHOD Distribution — Igor pro version

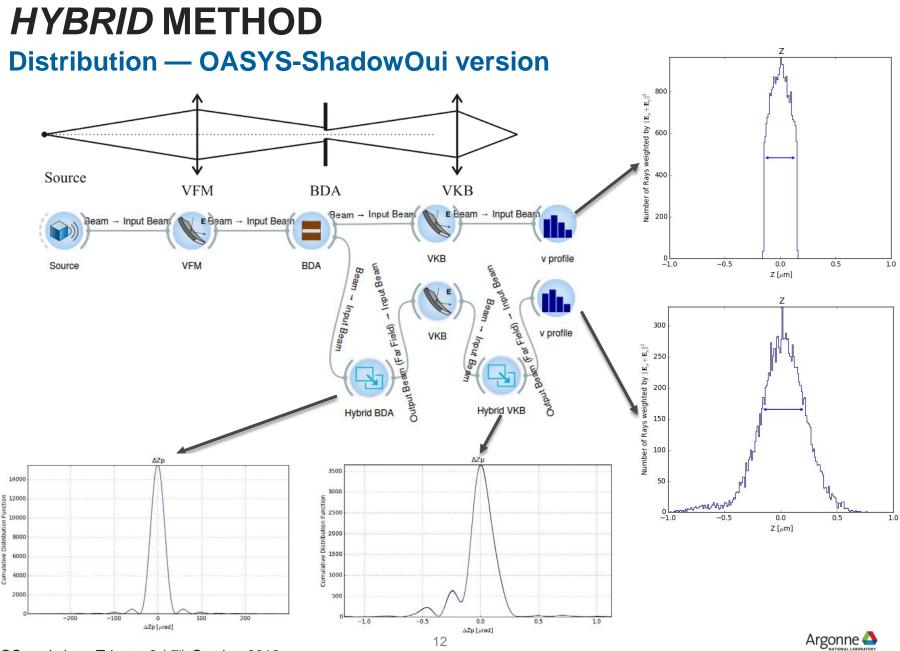
🏊 sh 🗖 🔍 🔀	hybrid_gui:	
Shadow working directory	Hybrid working directory Cxop2.3:tmp:	Run HYBR
C:xop2.3:tmp:	O.E. number 1	
Shadow3 directory	Screen number at 0 distance after OE 2	Rerun (no file
C:xop2.3:extensions:sha	Diffraction plane Z	Save shadow
Run Source	Calculation type 3.Elliptical mirror with slope error	Show plots
Number of OEs 2	Focal length (use SIMAGE if <0) 200	Close plots
Star file type 🛛 star 💽	Distance to image (use T_IMAGE if <0) 200	Post run studies
Run Trace	Or, select wave use file	Slope error st
Read Good only	Near-field calculation YES 💌	longitudinal profil
Read Shadow File	Numerical control parameters	
Write Shadow File	Number of bins for I(X) histogram 200	
Column X 💌	Number of bins for I(Z) histogram 200	
Get A Single Column	Number of diffraction peaks 5	
Read Angle File	Maximum number of points for FFT 100000	
Histogram 2d		
Histogram 1d	Important! Length unit in SHADOW mm	
Close plots	Result platting control	
Rays from Spectra	Result histogram range (X) user unit 🕘	
	Result histogram number of bins (X) 401 🕀	Closen er ren ett
	Result histogram range (Z) user unit 0.0005 🐺	Clean everyth
	Result histogram number of bins (Z) 101	Reset GUI



Argonne

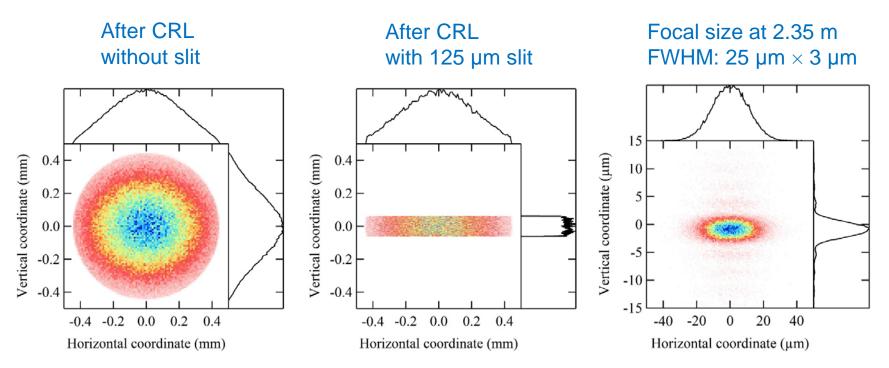






Simple aperture, CRL

- Current APS: E = 7350 eV undulator A, $\sigma_x = 275 \mu m$, $\sigma_y = 12.6 \mu m$
- Be parabolic lenses with R = 0.2 mm and N = 7, at 57 m from source, f = 2.26 m



 CRL was ray traced though individual lenses and the hybrid code was applied once after the CRLs.

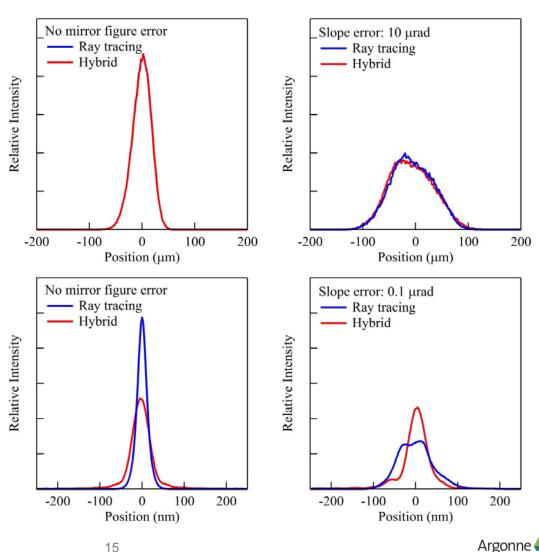


OUTLINE

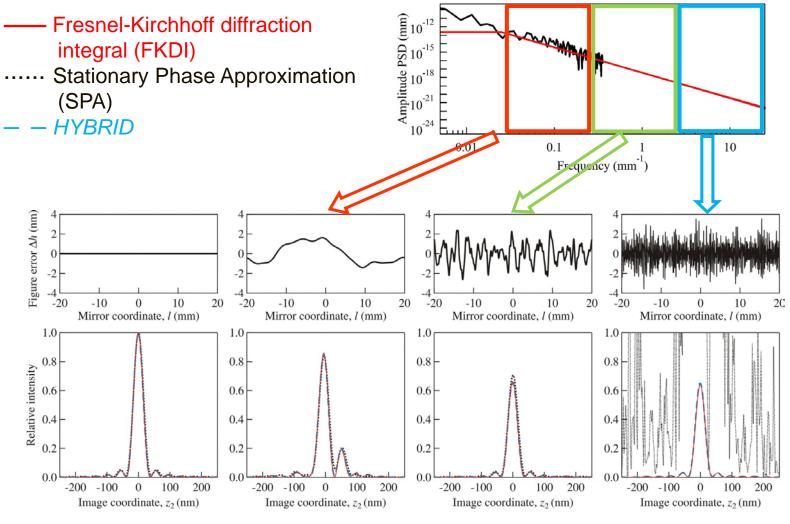
- Beamline optics simulation at APS
- HYBRID method
- Non-ideal optics: simulation
- Non-ideal optics: specification
- Mutual optical intensity propagation

Mirror with figure errors

- Geometric opics $\sigma = 270 \ \mu m$ $\sigma' = 12 \mu rad$ p = 30 m $q = 2 \, {\rm m}$ $L = 1 \, {\rm m}$
- Diffraction limited mirror $\sigma = 2 \,\mu m$ $\sigma' = 30 \mu rad$ p = 30 mq = 0.2 mL = 0.2 m

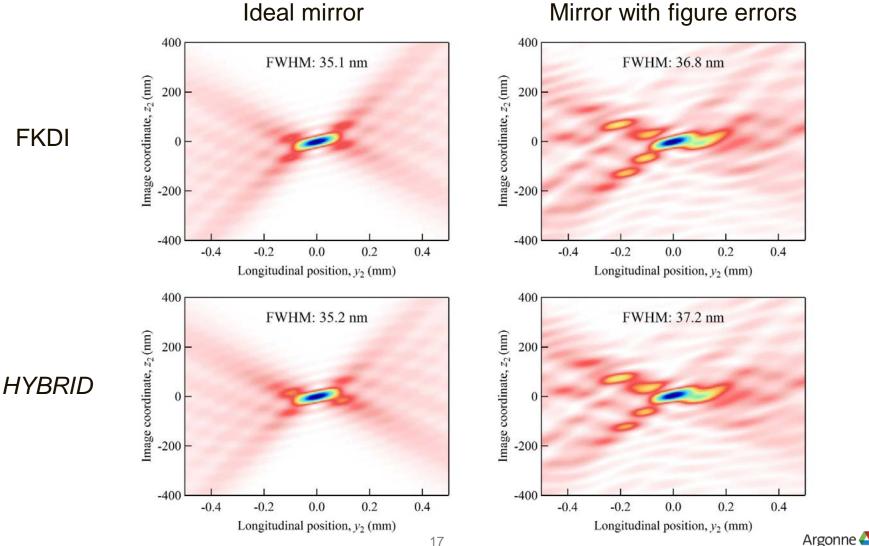


Diffraction-limited focusing mirrors with figure errors



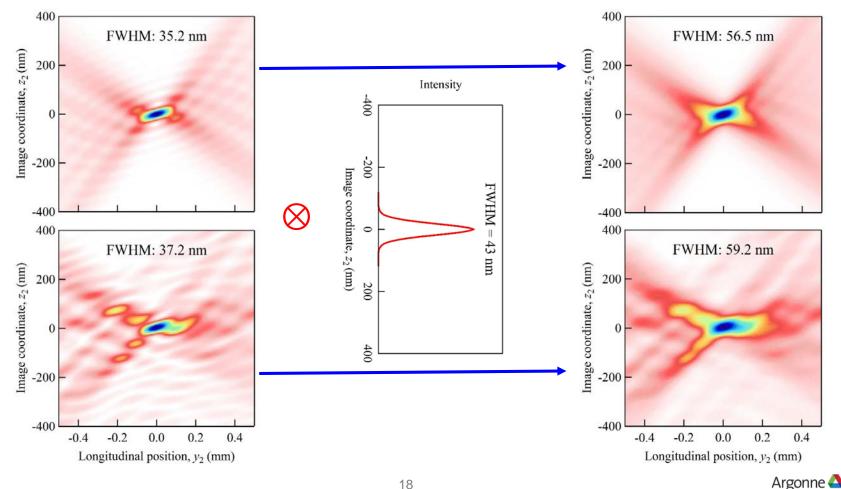


Near-field propagation



Near-field propagation

Mirror illuminated by an extended Gaussian source with the size of 20 µm (RMS) and divergence of 3 µrad (RMS).



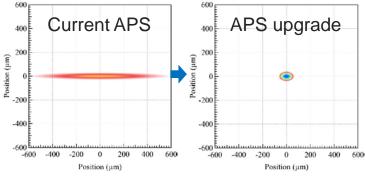
OUTLINE

- Beamline optics simulation at APS
- HYBRID method
- Non-ideal optics: simulation
- Non-ideal optics: specification
- Mutual optical intensity propagation



Motivation and basic consideration

 New light sources and upgrades



 Require mirrors with super precise figure:

<1 nm P-V height error <50 nrad RMS slope error and super smooth surface:

<0.1 nm RMS roughness

SOS workshop, Trieste, 3rd-7th October 2016

- Geometrical optics approach:
 - To ensure the source are not broadened by more than 20% (the aberration contribution is less than half of the source size), the slope error of the mirror located at distance D should be

$$\sigma_{\rm SE} < \frac{\Sigma}{4D}.$$

For *D* = 30 m: $\sigma_{\text{SE, H}}$ <0.2 µrad, $\sigma_{\text{SE, V}}$ <0.06 µrad

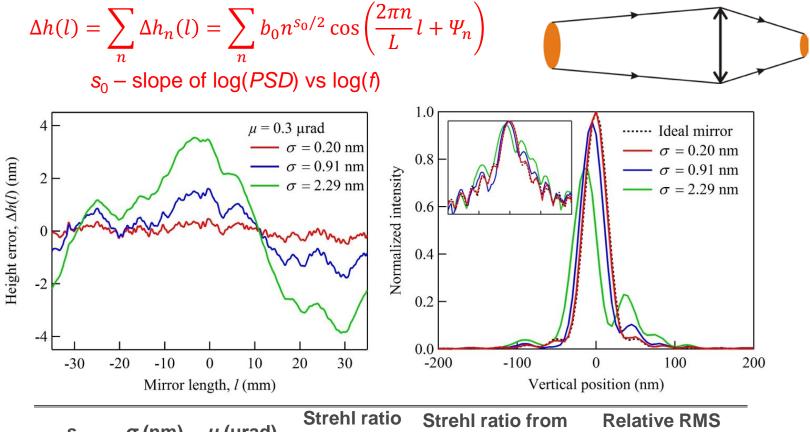
- Wave optics approach:
 - Rayleigh criterion ¼ wave P-V wavefront error
 - Maréchal criterion

$$\sigma_{\rm HE} < \frac{\lambda}{28\sin\theta}$$

At 10 keV, θ = 3 mrad: $\sigma_{\rm HE}$ <1.5nm



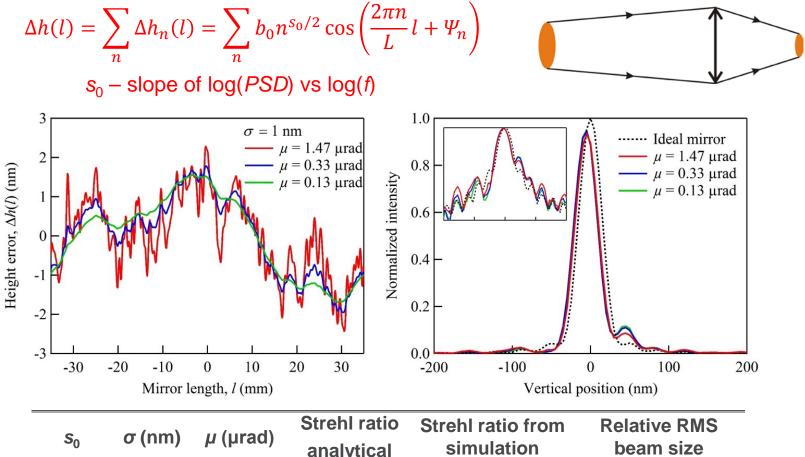
Diffraction limited focusing, 1000:1, 70 mm long mirror



	S ₀	σ (nm)	μ (µrad)	Strehl ratio analytical	Strehl ratio from simulation	Relative RMS beam size
_	-1.5	0.20	0.30	1.00	1.00	1.00
	-2.5	0.91	0.30	0.93	0.96	1.19
	-3.5	2.29	0.30	0.54	0.76	1.91



Diffraction limited focusing, 1000:1, 70 mm long mirror



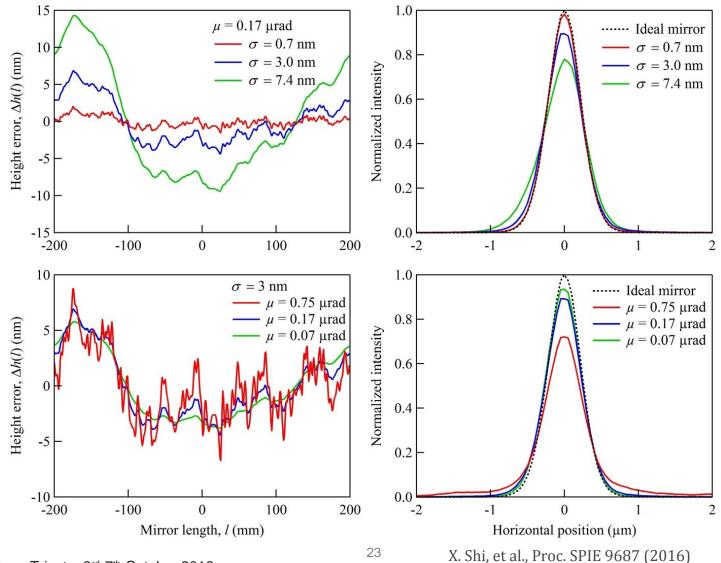
S ₀	σ (nm)	μ (µrad)	analytical	simulation	beam size
-1.5	1.0	1.47	0.91	0.93	1.17
-2.5	1.0	0.33	0.91	0.95	1.21
-3.5	1.0	0.13	0.91	0.95	1.22

SOS workshop, Trieste, 3rd-7th October 2016

X. Shi, et al., Proc. SPIE 9687 (2016)

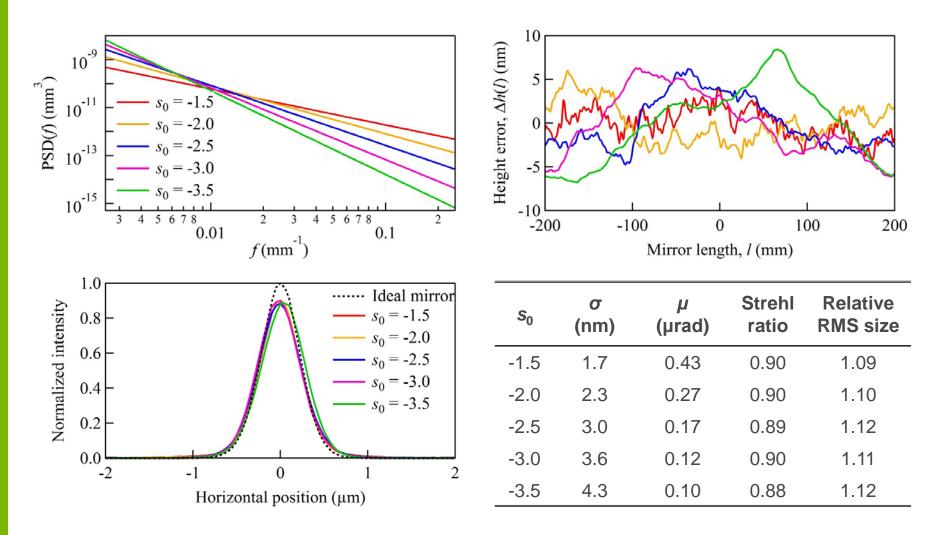


Non-diffraction limited focusing, 100:1, 400 mm long mirror



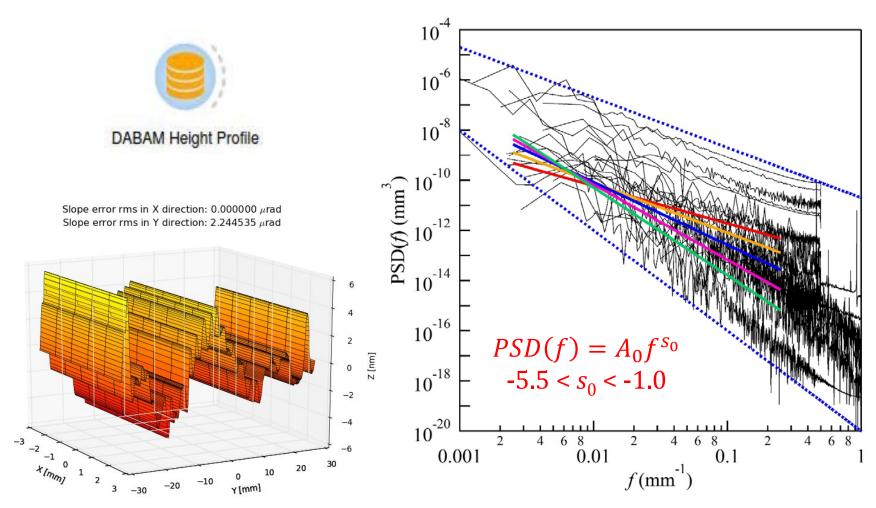
Argonne 🍊

Non-diffraction limited focusing, 100:1, 400 mm long mirror



Argonne 🦨

DABAM — an open-source database of x-ray mirrors metrology



Sanchez, M. et al. J. Synchrotron Rad. (2016).



OUTLINE

- Beamline optics simulation at APS
- HYBRID method
- Non-ideal optics: simulation
- Non-ideal optics: specification
- Mutual optical intensity propagation

Basic equations

- Collaboration with Shanghai Synchrotron Radiation Facility
- Mutual coherence function describes the correlations between two complex scalar values of the electric field

$$\Gamma_{12}(\tau) = \langle u(P_1, t + \tau)u^*(P_2, t) \rangle$$

- In case τ = 0, it becomes the mutual optical intensity (MOI)

$$\Gamma_{12}(0) = J(P_1, P_2) = \langle u(P_1, t)u^*(P_2, t) \rangle$$

The four-dimensional function J(P₁, P₂) describes the optical information of the wavefront, including the distribution of electric field and correlations between every two points. The propagation of MOI from wavefront P to wavefront Q is represented by equation

$$J(Q_1, Q_2) = \iint \iint J(P_1, P_2) \exp\left[-j\frac{2\pi}{\overline{\lambda}}(r_2 - r_1)\right] \frac{\chi(\theta_1)}{\overline{\lambda}r_1} \frac{\chi(\theta_2)}{\overline{\lambda}r_2} dS_1 dS_2$$

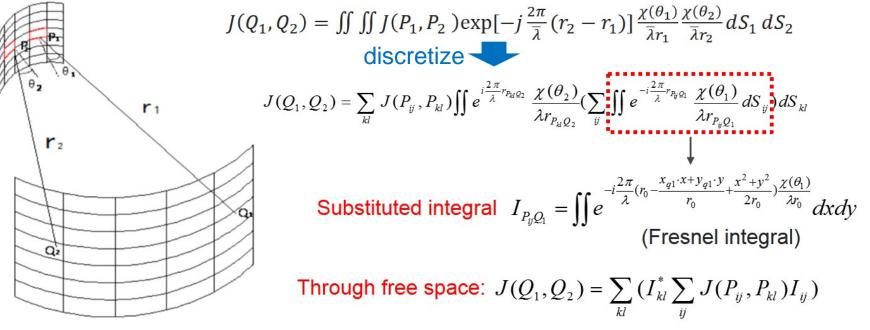
The degree of coherence between two points is defined as

$$\gamma_{12} = \frac{|J_{12}|}{\sqrt{I_1 I_2}}$$

where I_1 and I_2 are the intensities at Q_1 and Q_2 , respectively.

Free space propagation

- The wavefront at the source plane is separated into many elements, assumed that in every element the beam has full coherence and constant complex amplitude. It is valid as long as the dimension of the element is much smaller than the coherent length and beam spot size
- The propagation of each element is calculated with Fresnel approximations
- The MOI at the image plane after propagation can be obtained from the sum of the contributions of all elements on the source plane.



X. Meng et al. Opt. Express 23, 29675 (2015).
X. Meng et al. Acta Optica Sinica 33, 0734001 (2013)

SOS workshop, Trieste, 3rd-7th October 2016

Mirror with figure errors

The amplitude spread function of the reflecting mirror is given by

$$K(Q,P) = t(P) \exp\left[i\frac{2\pi}{\lambda}\Gamma(Q,P)\right]\delta[P - \tilde{P}(Q)]$$

- t(P) is the complex amplitude transmission function
- $\Gamma(Q, P)$ is the optical path between the incident and exit wavefronts
- $-\tilde{P}(Q)$ is the coordinate transformation for points on the two wavefronts
- The MOI at the reflecting plane can be expressed as

$$J_r(Q_1, Q_2) = \iint \iint J_i(P_1, P_2) K(Q_1, P_1) K^*(Q_2, P_2) dS_1 dS_2$$

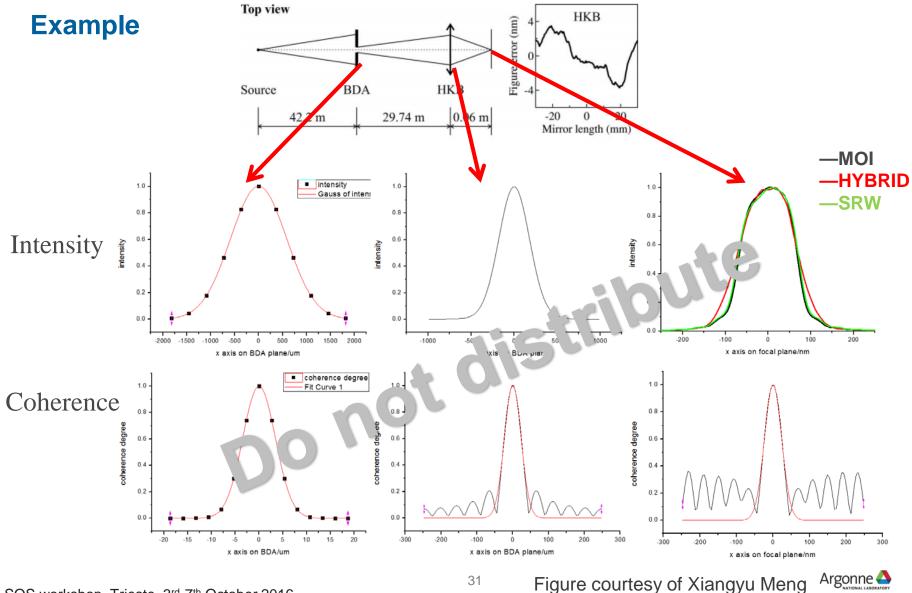
• Use the local ray tracing to get the path length $\Gamma(Q, \tilde{P}(Q))$, then

$$J_r(Q_1,Q_2) = J_i\left(\tilde{P}(Q_1),\tilde{P}(Q_2)\right)t\left(\tilde{P}(Q_1)\right)t^*\left(\tilde{P}(Q_2)\right)\exp\{i\frac{2\pi}{\lambda}\left[\Gamma\left(Q_1,\tilde{P}(Q_1)\right) - \Gamma\left(Q_2,\tilde{P}(Q_2)\right)\right]\}$$

Main feature

- Propagation of the MOI through the entire beamline
 - Starts with the real source (SPECTRA) MOI function or Gaussian Schell model
 - Propagates through beamline optics: free space, aperture, ideal optics, optics with figure errors.
 - Provides both the intensity and coherence information at any position of the beamline, full results can be stored and carried over.
 - Tread-off between efficiency and accuracy





ACKNOWLEDGEMENT

APS & APS-U Ruben Reininger Lahsen Assoufid Kwang-Je Kim Ryan Lindberg Nicholas Sereno

Dean Haeffner Jonathan Lang

BSRF Yingbo Shi ESRF Manuel Sanchez del Rio

Elettra Luca Rebuffi

SSRF Xiangyu Meng Yong Wang Renzhong Tai

THANK YOU!

